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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Toshiro Mitsuhashi et al.

Group Art Unit: 2818

Application No. 10/766,483

Examiner: Tran, Long K.

Filed: January 29, 2004

For: FERROELECTRIC ELEMENT AND METHOD FOR MANUFACTURING THE SAME

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:

In response to the Office Action of June 17, 2005, Applicants elect the invention of Group I, Claims 1-9, drawn to a semiconductor device. The election is without traverse.

Respectfully submitted,

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